

Notice of References Cited	Application/Control No. 10/590,959		Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner ROBERT JONES JR.		Art Unit 1796	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,541,033	04-2003	Shah, Subodh	424/486
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	M	US-			

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	V	Ming-Hsi Huang, Suming Li, Jean Coudane, Michel Vert; Macromol. Chem. Phys. 2003, 204, 1994-2001
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.